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GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

April 30, 2025

IGI Report Number **LG702591915**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **7.05 X 5.03 X 3.40 MM**

GRADING RESULTS

Carat Weight **1.19 CARAT**

Color Grade **D**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG702591915**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

LG702591915
Report verification at igi.org

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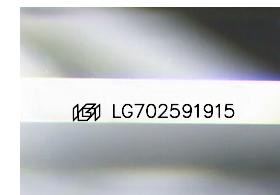
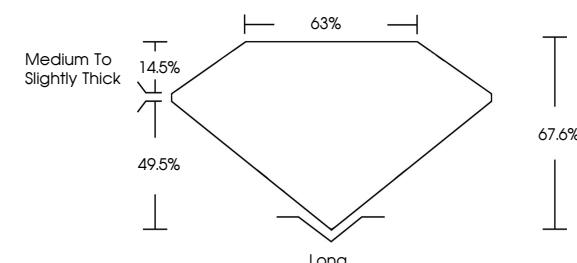
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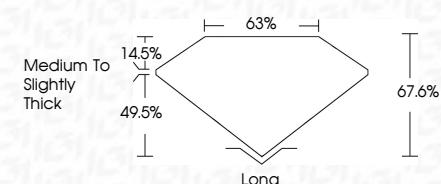
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PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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EMERALD CUT

7.05 X 5.03 X 3.40 MM

1.19 CARAT

D

VVS 2

67.6%

63%

Medium To Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

None

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